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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date September 16, 2008

In re the Application of

Nobuo NAITO et al.

Group Art Unit: 2831

Application No.: 10/580,414

Examiner: H. NGO

Filed: May 23, 2006

Docket No.: 128132

For: ELECTROMAGNETIC WAVE SHIELDING FILM AND METHOD FOR PRODUCING THE SAME

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

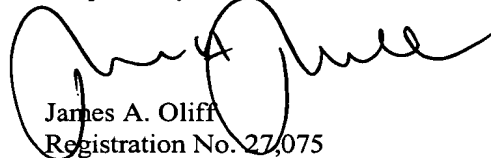
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 17, 2008, an extension of time for a period of 3 months is hereby requested. Attached hereto is our Check No. 209966 in the amount of \$1050 in payment for:

<u> </u>	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)
<u> X </u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Rodney H. Rothwell, Jr.
Registration No. 60,728

JAO:RHR/mcp

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
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